



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG769671904
Report verification at igi.org

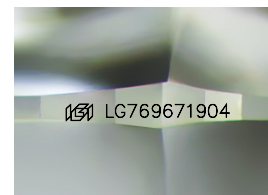
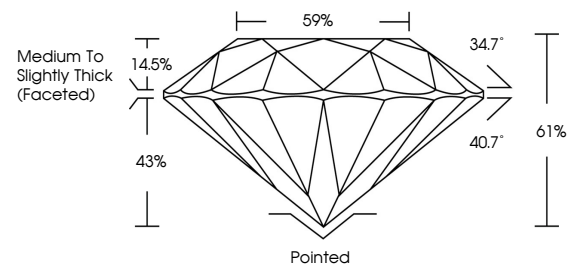
February 2, 2026	
IGI Report Number	LG769671904
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	7.40 - 7.46 X 4.53 MM
GRADING RESULTS	
Carat Weight	1.55 CARAT
Color Grade	F
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	151 LG769671904

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

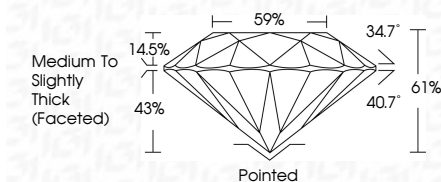
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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GRADING RESULTS	
Carat Weight	1.55 CARAT
Color Grade	F
Clarity Grade	VVS 2
Cut Grade	IDEAL



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG76967190A
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



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February 2, 2026
IGI Report No LG769671904
ROUND BRILLIANT

7.40 - 7.45 X 4.53 MM	1.55 CARAT
Carat Weight	F
Color Grade	VVS 2
Clarity Grade	IDEAL
Cut Grade	61%
Depth	59%
Table	Medium to Slightly Thick Faceted
Girdle	Pointed
Culet	EXCELLENT
Polish	EXCELLENT
Symmetry	NONE
Fluorescence	VERY WEAK
Comments	6011574525071004

Comments:
This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.